

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA et al.

Group Art Unit: 2851

Application No.: 09/769,832

Examiner:

R. FULLER

Filed: January 26, 2001

Docket No.: 108455

For:

PROJECTION EXPOSURE APPARATUS AND METHOD, CATADIOPTRIC OPTICAL

SYSTEM AND MANUFACTURING METHOD OF DEVICES

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- \boxtimes This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits after the filing of a Request for Continued Examination under 37 CFR §1.114. No certification or fee is required.
- 図 2. Translations of previously-submitted references are attached.

Respectfully submitted,

Mario A. Costantino Registration No. 33,565

MAC/cxm

Date: October 2, 2006

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| Form PTO-1449 US Dept. of Commerce (REV. 1/06) PATENT & TRADEMARK OFFICE | | | ATTY DOCKET NO. 108455 | | APPLICATION NO. 09/769,832 | | | | | |
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| INFORMATION DISCLOSURE STATEMENT | | | | | | | | | | |
| (Use several sheets if necessary) | | | APPLICANT(S) Yasuhiro OMURA et al. | | | | | | | |
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Date: October 2, 2006